

MAKING A MATERIAL DIFFERENCE

Comparison of monochromatic and broadband optical monitoring for deposition of non-quarter wave filter designs

Symposium OCLA 2021 March 30 – 31, 2021

Binyamin Rubin¹, Kyle Godin¹, Matthias Falmbigl¹, Jason George¹, Riju Singhal¹,

David Deakins²

¹Veeco Instruments, 1 Terminal Drive, Plainview, NY 11787 USA

²Meliora Scientific, 328 Air Park Drive, Suite 100, Fort Collins, CO 80524 USA



Single Wavelength And Broadband Monitoring Hardware

OMS Type	Wavelength Selectivity	Spectral range, nm	Spectral resolution, nm	Signal-to-noise ratio *
Monochromatic	Grating Monochromator+ UV-Vis, IR detectors	Vis: 300 - 1100 NIR: 900 - 2000	Variable <0.5	Typical 1:1,000
Monochromatic	Tunable laser	NIR: 1260-1640	Fixed <0.1	Up to 1:10,000
Broadband	Grating+ CCD/photodiode array	Vis: 300-1100 NIR: 900-1700	Fixed 1.5-3	Typical 1:300

* Affected by substrate rotation, vibration etc



Optical Monitoring Strategies

Level/spectrum matching

o Layers terminated at pre-calculated transmittance/reflectance values

- Curve fitting
 - o Fit simple functional form, e.g. parabola
 - o OR calculate time interval between extrema
 - Model predicts termination point
- Thin film physics model based fitting
 - o Fit thin film model parameters (thickness, dispersion) in real time
 - \circ Model predicts layer termination point when given condition is met



Theoretical Analysis of Noise Sensitivity

Effect of random errors in transmittance data on optical monitoring



Standard deviation of transmittance measurements

Sensitivity of transmittance value to layer thickness variation

Denominator is many times more for broadband – lower layer errors expected

A.Tikhonravov, M.Trubetskov, and T. Amotchkina, "Investigation of the effect of accumulation of thickness errors in optical coating production by broadband optical monitoring," Appl. Opt. 45, 7026-7034 (2006)



CONFIDENTIAL

Theoretical Analysis of Noise Sensitivity

- Calculated error levels for 72-layer Short Wave Pass filter
 - o Broadband: 400-1000 nm
 - o Monochromatic: 400 nm
 - Measurement noise level: 0.1% RMS



Order of magnitude lower errors expected with broadband monitoring



Defining a Monochromatic Strategy

- Layer sensitivity choose the wavelength where there is the greatest change during the layer
- "Trinary Mapping"*
 - $\circ\,$ High change of T% during the layer
 - o Layer end: not near a turning point
 - $\circ~$ Layer end: high derivative of T%
 - Layer end: T% above a minimum (avoids a high noise situation)
 - Low transmission variability within wavelength window (to account for linewidth errors)
 - $\,\circ\,$ Bonus criteria: visible max and min during the layer
- Manufacturing simulation of test strategy

*Vignaux, Mael, et al. "Trinary Mappings: A Tool for the Determination of Potential Spectral Paths for Optical Monitoring of Optical Interference Filters." *Applied Optics* 57, no. 24, 2018



Fig. 1. Computer-simulated monitoring curve of %R versus physical thickness monitoring at 380 nm in reflectance for the four-layer AR.

R. R. Willey, "Simulation comparisons of monitoring strategies in narrow bandpass filters and antireflection coatings," Appl. Opt. 53, A27-A34 (2014).).



Experimental Work – Broadband and Monochromatic

- Several monochromatic filters have been demonstrated with excellent results using Trinary Mapping to define a strategy and POEM to monitor
- What are the limitations of the method? (a work in progress)
- We chose two challenge filters to fabricate



Experiment – Short Wave Pass

Theoretical Spectrum



- 72 Layers
- All non-QWOT

Broadband Experiment



Simple strategy: monitor 400-1000 nm, fit to theoretical spectrum.



Short Wave Pass – Monochromatic Strategies



<u>Strategy 1</u> Best Single WL	<u>Strategy 2</u> Balance the number of WL while passing through some disallowed regions	<u>Strategy 3</u> Minimum # of WL while strictly passing through "green" areas
500 nm	480 nm	468 nm
	495 nm @ layer 21	390 nm @ layer 14
	488 nm @ layer 41	388 nm @ layer 30
		392 nm @ layer 44
		388 nm @ layer 59

- Passes all 5 criteria
- Does not pass all 5 criteria
- Passes all criteria and there is a max and min within the layer

For monochromatic monitoring, the user must carefully design the monitoring strategy.



Short Wave Pass – Single Wavelength Experiment



- All monitored using Percent of Optical Extremum monitoring (POEM)
- No monochromatic strategy was able to produce the filter.
- The strategy with many wavelength changes underperformed.



Multi-Notch: Experiment



- 100 Layers
- All non-QWOT

Complex control strategy: broadband for most layers and then switching to single wavelength (simple level cut)..



CONFIDENTIAL

Multi-Notch: Broadband and Monochromatic



Monochromatic Experiment



Wavelength	Layers	
569	1-14	
453	15-84	
469	85-100	2



Conclusions

- Broadband monitoring has several advantages for monitoring filters with non-quarter-wave layers
 - o Easier control strategy set-up
 - Stronger error self-compensation
 - o "What you see is what you get"
- Monochromatic monitoring has some capability for monitoring nonquarter wave layers
 - o More complex strategy is required compared to broadband
 - Main advantage is high spectral resolution relevant for narrow band pass filters





MAKING A MATERIAL DIFFERENCE

Model Based Fitting

- Real-time fit of layer thickness
- Sequential: fit only current layer thickness

$$F_{s}\left(d_{j}^{s}\right) = \left[\frac{1}{N}\sum_{i=1}^{N} \left(\frac{T_{meas}^{s}(j)\left(\lambda_{i}\right) - T_{calc}^{s}(j)\left(\lambda_{i}, d_{1}, ..., d_{j-1}, d_{j}^{s}\right)}{\Delta T_{s}\left(\lambda_{i}\right)}\right)^{2}\right]^{2}$$

T- transmittance, *d* –thickness, λ – wavelength, *N*- number of wavelengths, ΔT - transmittance measurement error Error propagation can be a problem

• Full triangular algorithm: fit current and all previous layers

$$F_{T}^{(J)}\left(\boldsymbol{d}_{1},...,\boldsymbol{d}_{j}\right) = \left[\frac{1}{JN}\sum_{j=1}^{J}\sum_{i=1}^{N} \left(\frac{T_{meas}^{T}\left(j\right)\left(\boldsymbol{\lambda}_{i}\right) - T_{calc}^{T}\left(j\right)\left(\boldsymbol{\lambda}_{i},\boldsymbol{d}_{1},...,\boldsymbol{d}_{j}\right)}{\Delta T_{T}\left(\boldsymbol{\lambda}_{i}\right)}\right)^{2}\right]^{2}$$

- Potential to detect errors in previous layers
- More time- consuming, sometimes used between layers

T. Amotchkina, et al. "Comparison of algorithms used for optical characterization of multilayer optical coatings." Appl. Opt. 50, 3389-3395 (2011).